

## PATENT APPLICATION

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Kenichi SHIRAISHI

Group Art Unit: 2852

Application No.:

10/588,146

Docket No.: 128985

Filed: November 6, 2006

For:

EXPOSURE APPARATUS, DEVICE MANUFACTURING METHOD,

MAINTENANCE METHOD, AND EXPOSURE METHOD

# REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the corrected filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

Mario A. Costantino Registration No. 33,565

James E. Golladay, II Registration No. 58,182

MAC:JEG/aml

Date: September 7, 2007

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DEPOSIT ACCOUNT USE **AUTHORIZATION** Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461





UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandra, Virginia 22313-1450 www.uspto.gov

| APPL NO.   | FILING OR 371(c)<br>DATE | ART UNIT         | FIL FEE REC'D |   | ATTY.DOCKET NO          | TOT CLMS | IND CLMS |
|--|--------------------------|------------------|---------------|---|-------------------------|----------|----------|
| 10/588,146   | 11/06/2006               | 2852             | 1160          |   | 128985                  | 17       | 2        |
| 25944<br>OLIFF & BERRIDGE, PLC<br>P.O. BOX 19928<br>ALEXANDRIA, VA 22320 |                          | AUG 17 2007      |               | CONFIRMATION NO. 3604 CORRECTED FILING RECEIPT *OC0000000025393017* |                         |          |          |
|  |                          | OLIFF & BERRIDGE |               |   | Date Mailed: 08/15/2007 |          |          |

Receipt is acknowledged of this nonprovisional patent application. The application will be taken up for examination in due course. Applicant will be notified as to the results of the examination. Any correspondence concerning the application must include the following identification information: the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

### Applicant(s)

Kenichi Shiraishi, Saitama-shi, JAPAN;

#### **Assignment For Published Patent Application**

Nikon Corporation, Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number <u>25944</u>.

#### Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP05/01827 02/08/2005

#### Foreign Applications

JAPAN 2004-033679 02/10/2004

If Required, Foreign Filing License Granted: 03/30/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is US10/588,146

Projected Publication Date: Not Applicable

Non-Publication Request: No

#### Early Publication Request: No

Title

Exposure apparatus, device manufacturing method, maintenance method, and exposure method

#### **Preliminary Class**

399

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